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agus 6, 3057

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 09/833,029

Confirmation No. : 1338

Applicant: Jason B. Elledge

. Jason D. Encuge

: April 10, 2001 Attorney Docket No.: 500188.03

Art Unit : 3723

Filed

Customer No.

: 27,076

Examiner : Eziamara Anthony Ojini

Title : APPARATUS FOR IN-SITU OPTICAL ENDPOINTING ON WEB-FORMAT

PLANARIZING MACHINES IN MECHANICAL OR CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE SUBSTRATE ASSEMBLIES

AND METHODS FOR MAKING AND USING THE SAME

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicant wishes to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449 (copies of the cited references, as required under 37 C.F.R. § 1.98, are enclosed). Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicant's duty to disclose all information he is aware of which is believed relevant to the examination of the above-identified application, applicant believes that his invention is patentable.

Please acknowledge receipt of this Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Respectfully submitted,

DORSEY & WHITNEY LLP

Mark W. Roberts, Ph.D. Registration No. 46,160

MWR:pep

Enclosures:

Postcard

Check

Fee Transmittal (+ copy)

Request for Continued Examination (+ copy)

Copy of Information Disclosure Statement

Form PTO-1449

Cited References ()

Copy of Related Application

1420 Fifth Avenue, Suite 3400 Seattle, WA 98101 Telephone (206) 903-8800 Facsimile (206) 903-8820

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FORM PTO-1449 (REV.7-80)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. 500188.03

APPLICATION NO. 09/833,029

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INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT(S) Jason B. Elledge

FILING DATE April 10, 2001 GROUP ART UNIT 3723

APR 1 2 2004

U.S. PATENT DOCUMENTS

8 x	المخت	U.S. PATENT DOCUMENTS					
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	AA	6,426,232	07/30/02	Litvak	438	8	
	AB	6,323,046	11/27/01	Agarwal	438	8	
	AC	6,285,035	09/04/01	Taravade	250	559.22	
	AD	6,241,847	06/05/01	Allman et al.	438	8	
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	AR	5,413,941	05/09/95	Koos et al.	438	16	
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OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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Applied Materials, "Dielectric Deposition,"

http://www.appliedmaterials.com/products/pdd.html, printed 3/2/99 ΑV

EXAMINER

DATE CONSIDERED

* EXAMINER:

Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).